U.SPakis	stan Centre fo ANCED ENERGY SERVICE F	ciences & Technology (NU or Advanced Studies in End MATERIALS & SYSTEMS LAB REQUEST FORM –	
	MICROFABR	CATION FACILITY	For Official Use
			Serial No:
Faculty Student (MS/PhD)	External		Date:
Name:		Dept. /Organization:	
Registration #:		Contact #:	
Email:		Project Supervisor:	
Project Title:			
Name of Service Required: Thermal Evaporation, Magnetron Sputtering, Chemical Vapor Deposition, Spin coating, Dip Coating, Electrospinning, Ultra sonic Spray, Electron Beam PVD, Other			
Analysis Details: 1. What do you want to do? 2. General and specific goal/s? 3. Other relevant info?			
Detailed Sample Description: Sample Code, Substrate (Nature, Chemistry, Size, Shape & History), Chemical Composition & Size of Granules/Target to be Coated, Nature & Purity of Gases, etc.			
Process Conditions: Base Pressure, Approx. Film Thickness, Gas Pressure, Substrate Temp, Deposition Rate, Power, Time, etc.			

## \*Signatures & Stamps

Project Supervisor:

(Assoc. Prof. Dr. Ghulam Ali, In- charge AEMS Lab, USPCAS-E)

\*Applicant and his supervisor must address all safety aspects. AEMS Lab will not accept samples which are radioactive, bio-hazardous, explosive, volatile/dirty etc. Applicant must furnish max information as asked in the above table, please. For each sample, a new service request form must be filled. In case of reports/publications, the applicant should acknowledge the use of these instruments at the AEMS Lab, USPCAS-E.

	F	or	Lab/	<u>'USP</u>	CAS	Usage	Only
--	---	----	------	-------------	-----	-------	------

Sample received on:	Processed by:
Analysis Results sent on:	Results Prepared by:
Result to be sent (Email / Courier):	
Charges received (Amount & Cheque No.):	